PATENT APPLICATION

Atty. Docket No.: Applicant:

9898-290

Serial No.:

10/619,821

Filing Date:

Geun-Hee CHO and Kyu-Hyoun KIM July 14, 2003

Group:

2661



INFORMATION DISCLOSURE CITATION FORM PTO-1449 (Modified)

U.S. PATENT DOCUMENTS

Exam <u>Init</u>	<u>Ref</u>	Document Number	Issue <u>Date</u>	<u>Name</u>	<u>Class</u>	Sub <u>Class</u>
TB		6,125,157	Sep. 26, '00	Donnelly, et al.	~	
TB		2001/0030562	Oct. 18, '01	Kim, et al.	<u> </u>	

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TB		EP 0 930 709	Jul. 21, '99	Europe	Yamaguchi, et al.
TB		DE 197 03 986	Dec. 4, '97	Europe	Harufusa, et al.

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TB		English language abstract of European Publication No. DE 197 03 986 (in the form of U.S. Patent No. 5,883,534, issued on Mar. 16, '99)
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Exam		

Examiner: /Tesfaldet Bocure/

In re application of:

Geun-Hee CHO and Kyu-Hyoun KIM

Conf. No.

7205

Serial No.

10/619,821

Examiner:

Not yet assigned

Filed:

July 14, 2003

Art Unit:

DELAY LOCKED LOOP CIRCUIT FOR INTERNALLY CORRECTING DUTY

2661

For: O1

CYCLE AND DUTY CYCLE CORRECTION METHOD THEREOF

INFORMATION DISCLOSURE CITATION FORM PTO-1449 (Modified)

U.S. PATENT DOCUMENTS

Exam <u>Init</u>	<u>Ref</u>	Document <u>Number</u>	Issue <u>Date</u>	<u>Name</u>	Class	Sub <u>Class</u>
TB		5,614,855	Mar. 25, 97	Lee et al.	-	

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<u>Ref</u>

Author, Title, Date, Pertinent Pages, Etc.)

TB English language abstract of Korea Publication No. 2001-95537

Examiner: /Tesfaldet Bocure/

PATENT APPLICATION

IDS - 07/14/2003 Atty. Docket No.: 9898-290 Applicant: Geun-Hee Cho and Kyu-Hyoun Kim

Filing Date:

July 14, 2003

Serial No.

Not Yet Assigned

Group: .

Not Yet Assigned

INFORMATION DISCLOSURE CITATION FORM PTO-1449 (Modified)

U.S. PATENT DOCUMENTS

Exam <u>Init</u>	Ref		Document Number	Issue <u>Date</u>	Name	Class	Sub <u>Class</u>
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English translation of abstract for Japanese Patent No. JP1081523

Examiner: /Tesfaldet Bocure/

PATENT APPLICATION

Atty. Docket No.: .

9898-290

Serial No.:

10/619,821

Applicant: Filing Date: Geun-Hee CHO and Kyu-Hyoun KIM July 14, 2003

Group:

2634

INFORMATION DISCLOSURE CITATION FORM PTO-1449 (Modified)

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Examiner: /Tesfaldet Bocure/